**PATENT** 

Attorney Docket No. 071469-0305917

Client Reference: RAJ-013

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: NORIAKI FUKIAGE, KATHERINA BABICH

Application No.:

Confirmation

No:

Filed:

November 6, 2003

Group No.:

Examiner

For: METHOD FOR DEPOSITING MATERIALS ON A SUBSTRATE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

# APPLICATION DATA SHEET 37 C.F.R. § 1.76

#### **BIBLIOGRAPHIC DATA**

## 1. Applicant information

First applicant: NORIAKI FUKIAGE

Citizenship: JAPAN Residence: Hartsdale, NY

Second applicant: KATHERINA BABICH

Citizenship: USA

Residence: Chappaqua, NY

### 2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

## 3. Application information

Title of Invention: METHOD FOR DEPOSITING MATERIALS ON A SUBSTRATE

Docket number assigned to this application: 071469-0305917

Suggested Classification:

Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 7

Type of application:

Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

## 4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

## 5. Assignee information

The assignee(s) of this application is/are:

Tokyo Electron Limited 3-6, Akasaka 5-chome, Minato-ku Tokyo, 107 JAPAN Extent of interest of assignee in application: 50%

International Business Machines Corporation New Orchard Road Armonk, NY 10504 Extent of interest of assignee in application: 50%

Date: November 6, 2003

Reg. No.: 28872

Tel. No.: (703) 905-2126 Customer No.: 00909 Signature of Practitioner

Dale S. Lazar

PILLSBURY WINTHROP LLP

P.O. Box 10500 McLean, VA 22102